

信頼性試験成績書

0.65um Process Technology Product and Package Legacy Fujitsu Reliability Engineering Test Report

Wafer Process : Aizu Fujitsu
Assembly : J-Devices

Reliability Test 1

Device Type : MCU 1
Package Type : Plastic LQFP-120 Package

Test Item	Test Condition	Tested Number		Tested Time	Failed Number
High Temperature Operation Life 高温連続動作試験	150 °C V _{DD} =Maximum Rating	55	(a)	1000h	0
Temperature Humidity Bias 高温連続動作試験	85 °C / 85% RH V _{DD} =Maximum Rating	25	(a)	1000h	0
Low Temperature Operation Life 低温連続動作試験	-55 °C V _{DD} =Maximum Rating	25	(a)	1000h	0
High Temperature Storage 高温保存試験	150 °C	25	(a)	1000h	0
Temperature Cycling 温度サイクル	-65°C~150°C	55	(a)	200cyc	0
Pressure Cooker Test	121°C, 100%RH: 2.03E5 Pa	55	(a)	168h	0
Pressure Cooker Test with Bias	121°C, 100%RH: 2.03E5 Pa V _{DD} =Maximum Rating	25	(a)	96h	0

(a) Pre-condition: Baking (125°C, 24h) +Moisture Absorption (85°C/85%RH, 24h) +IR 245°C Max.



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**	5769404	KUMI	Initial release.